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PATENT
MIC04 P-106

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Lynette
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group : 1763
Applicant : Imad Mahawili, PhD
Serial No. : 09/488,309
Filed : January 20, 2000
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAIL

I certify that the attached return postcard, Information Disclosure Statement, Form PTO-1449, and copies of information referenced herein are being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Assistant Commissioner for Patents
Washington, D.C. 20231

on September 27, 2000.

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Enclosures



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Imad Mahawili, Ph.D
Serial No. : 09/488,309
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Group Art : 1763
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 CFR 1.51, 1.56, 1.97 and 1.98, Applicant submits herewith patents, publications or other information listed on attached Form PTO-1449 for consideration by the Examiner in connection with examination of the present application.

This Information Disclosure Statement is being filed: (a) within three months of the filing date of the national application; (b) within three months of the date of entry of the national stage as set forth in 37 CFR § 1.491 in the corresponding international application; or (c) before the Applicant is aware of any mailing date of a first Office Action on the merits, whichever occurs last.

This Information Disclosure Statement is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such.

Under 37 CFR 1.97(h), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists.

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Applicant : Imad Mahawili, Ph.D
Serial No. : 09/488,309
Page : 2

An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

IMAD MAHAWILI, PHD

By: Van Dyke, Gardner, Linn & Burkhart, LLP

September 27, 2000

Date

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